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APPLICATION NUMBER	FILING OR 371(c) DATE	FIRST NAMED APPLICANT	ATTY. DOCKET NO./TITLE
10/597.066	07/10/2006	Huaiie Chen	FIS920030342US1

CONFIRMATION NO. 5456

32074 INTERNATIONAL BUSINESS MACHINES CORPORATION DEPT. 18G BLDG. 300-482 2070 ROUTE 52 HOPEWELL JUNCTION, NY12533

Title: Method of forming thin sgoi wafers with high relaxation and low stacking fault defect density

Publication No. US-2007-0128840-A1

Publication Date: 06/07/2007

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